

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|-------|--|---|------------------|---------|------------------|
| L1 | 95330 | (wafer substrate) same (holder cassette convey\$3 collet) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/07 11:26 |
| L2 | 543 | (wafer substrate) same (holder cassette convey\$3 collet) and (first lower) adj2 (die chip ic) and (second upper) adj2 (die chip ic) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/07 11:28 |
| L3 | 259 | (wafer substrate) same (holder cassette convey\$3 collet) and (first lower) adj2 (die chip ic) and (second upper) adj2 (die chip ic) and stage | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/07 12:08 |
| L4 | 5 | abe-s-\$.in. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/07 11:32 |
| L5 | 0 | uebayashi-t-\$.in. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/07 11:32 |
| L6 | 0 | izumi-n-\$.in. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/07 12:08 |
| L7 | 705 | 438/109,113,118,455,458,460,462.ccls. and (wafer substrate) and (holder cassette convey\$3 collet transfer\$3 adj2 device) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/07 12:22 |
| L8 | 282 | 438/109,113,118,455,458,460,462.ccls. and (wafer substrate) and (holder cassette convey\$3 collet transfer\$3 adj2 device) and stage | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/07 12:29 |
| L9 | 183 | 257/666,672,676,723,724,777,782,783.ccls. and (wafer substrate) and (holder cassette convey\$3 collet transfer\$3 adj2 device) and stage | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/07 12:38 |

| | | | | | | |
|-----|-----|---|---|----|----|------------------|
| L10 | 877 | "198"/\$.ccls. and (wafer substrate) and (holder cassette convey\$3 collet transfer\$3 adj2 device) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/07 12:38 |
| L11 | 205 | "198"/\$.ccls. and (wafer substrate) and (holder cassette convey\$3 collet transfer\$3 adj2 device) and stage | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/07 12:40 |
| L12 | 154 | "269"/\$.ccls. and (wafer substrate) and (holder cassette convey\$3 collet transfer\$3 adj2 device) and stage | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/07 12:40 |